



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of	)	I hereby certify that this correspondence is being deposited with the United States Postal Service as first
Yamazaki et al.	)	class mail in an envelope addressed to: Commissioner for Patents,
Serial No.: 09/993,993	)	P.O. Box 1450, Alexandria, VA 22313-1450 on Sootember 3 2003
Filed: November 14, 2001	)	(Date of Deposit) Shannon Wallace
For: Semiconductor Device And Mo Of Manufacturing The Same	ethod )	Name of applicant, assignee, or Registered Rep.  Signature  Date
Art Unit: 2826	)	16 6
Examiner: T. Pham	)	RECT
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450		EIVED 11 2003
Sir:	AMENDMEN	

In response to the Office Action dated June 3, 2003, please amend the above-identified application as follows: